

Electroless Plating Chemicals & Services

Electroless metal plating chemicals and services

NANO3D provides Ni, Co and Cu electroless plating solutions and microfabrication plating services.

Key Benefits:

Conformal and uniform electroless plating

- Step coverage of over 95% in high aspect ratios features (vias and trenches)
- WIW thickness nonuniformity of < 2% @ 1 Sigma

Sulfur-free stabilizers

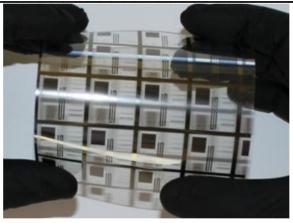
 The technology employs sulfur free stabilizer that drastically reduces decomposition of electroless plating solution.

Optimal Surface Roughness and Texture

- Smooth surface morphology
- Strong (111) texture

Wide variety of substrates

 The technology is applicable for the metallization of flexible (polymers, glass, ceramic, plastic, silicon et al.), patterned (vias & trenches) & stretchable substrates.



Electroless metal deposition on flexible substrates







Stabilizer free solution After Ni deposition



Selective electroless metal plating over a catalytic photoresist on glass substrate



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Electroless Ni & Co solutions

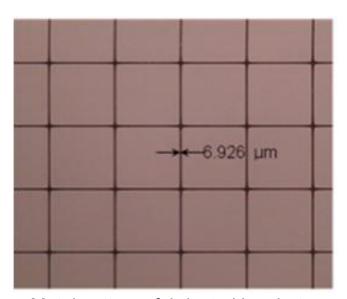
- Stock solution
- Reduction agent solution
 - Hypophosphite
 - DMAB
- Plating additives
 - Sulfur-free stabilizer
 - Wetting agent
- Alloying elements
 - W, Mo, Re, P, B
- Metrology Standards
 - LSL, Target, USL Stock Calibration Standards
 - LSL, Target, USL Additive Calibration Standards
 - Bath Metrology Reagents

Electroless Cu solution

- Stock solution
- Reduction agent solution
 - Formaldehyde
 - Glyoxylic acid
- Plating additives
 - Stabilizer
 - Wetting agent
- Alloying elements
 - Sn, Zn, Ni, Co, Pd
- Metrology Standards
 - LSL, Target, USL Stock Calibration Standards
 - LSL, Target, USL Additive Calibration Standards
 - Reagents for Plating Bath Metrology

Microfabrication plating services

- Photo-selective metal plating over variety of substrate (polymers, glass, silicon et al.) to form metal patterns down to 5 μm width.
- Applications include transparent metal mesh for touchscreens, barrier/seed layers for damascene metallization, MEMS and IoT interconnects et al.



Metal patterns fabricated by photoselective electroless plating

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